Attorney Docket No. 1003510-00016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Yoshihisa SAIMOTO et al.

Application No.: 10/506,806

September 7, 200

MAR 1 0 2006

Group Art Unit: 2811

Examiner: STEVEN HO YIN LOKE

Confirmation No.: 5415

Title: PRESSURE SENSITIVE ADHES FOR PROTECTION OF SEMICONDUCTOR WAFER

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Filing Date:

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The following extension of time is requested to: response to the official action mailed January 3, 2006, for

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	two months to	April 3, 2	006	□ \$2	225.00 (2252)	X s	\$450.00 (1252)	
	The shortened s	tatutory period	has been re	eset by	an Advisory A	Action	dated	
	An extension fee	of	is enclosed.					
	Charge to Deposit Acco				ount No. 02-4800.			
×	Charge \$	450.00 to	credit card.	Form	PTO-2038 is	attac	hed.	
1.21 that	Director is hereby may be required ber is submitted in d	y this paper, a	charge any a nd to credit	approp any ov	oriate fees undo verpayment, to	er 37 Depe	C.F.R. §§1.16, 1.17 and osit Account No. 02-4800	
			Respectfully submitted,					
			BUG	BUCHANAN INGERSOLL PC				
P.O. Box Alexandri (703) 836	a, Virginia 22313-	1404		Ву	Robert G. Mu	ykai	1. Mula-	
Date:	March 10, 2006				Registration N		28,531	

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Buchanan Ingersoll PC

March 10, 2006

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Date: